



**ELECTRONIC COPY**

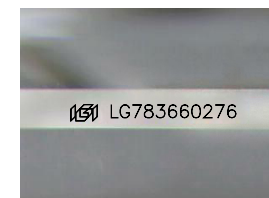
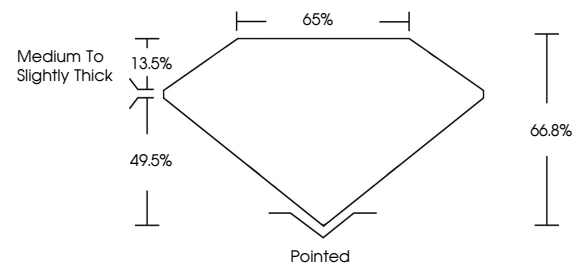
LG783660276  
Report verification at igi.org



March 21, 2026  
IGI Report Number **LG783660276**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **9.66 X 6.47 X 4.32 MM**  
**GRADING RESULTS**  
Carat Weight **2.32 CARATS**  
Color Grade **D**  
Clarity Grade **VS 1**  
Cut Grade **EXCELLENT**

March 21, 2026  
IGI Report Number **LG783660276**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED RECTANGULAR  
MODIFIED BRILLIANT**  
Measurements **9.66 X 6.47 X 4.32 MM**

**PROPORTIONS**

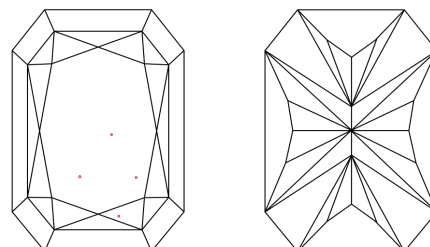


Sample Image Used

**GRADING RESULTS**

Carat Weight **2.32 CARATS**  
Color Grade **D**  
Clarity Grade **VS 1**  
Cut Grade **EXCELLENT**

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG783660276**

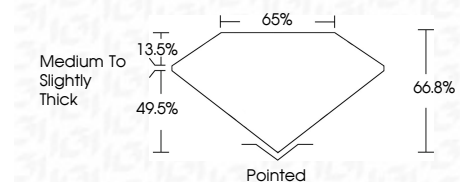
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG783660276**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



March 21, 2026  
IGI Report No LG783660276  
CUT CORNERED RECT. MODIFIED BRILLIANT  
9.66 X 6.47 X 4.32 MM  
2.32 CARATS  
D  
VS 1  
EXCELLENT  
66.8%  
65%  
Medium To Slightly Thick  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG783660276  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa